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December 17, 2003

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MAIL STOP PATENT APPLICATION

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Re:

Application of Satoshi YAMAMOTO and Takashi TAKIZAWA METHOD OF FORMING A PENETRATION ELECTRODE AND SUBSTRATE HAVING A PENETRATION ELECTRODE

Assignee: FUJIKURA LTD.

Our Ref. Q78469



Dear Sir:

Attached hereto is the application identified above comprising 15 sheets of the specification, including the claims and abstract and 3 sheets of drawings. Copies of an executed Declaration and Power of Attorney and Assignment will be submitted at a later date.

The Government filing fee is calculated as follows:

A check for the statutory filing fee of \$770.00 is attached. The USPTO is directed and authorized to charge all required fees, except for the Issue Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any overpayments to said Deposit Account. A duplicate copy of this transmittal letter is attached.



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Priority is claimed from:

Country

Application No

Filing Date

JAPAN

2002-370201

December 20, 2002

The priority document will be filed at a later date.

Respectfully submitted, SUGHRUE MION, PLLC

Attorneys for Applicant

Βv

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